

Docket Number
36856.1455

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki KANBARA et al. Application No.: 10/596,000 Confirmation No.: 1561 Filing or 371(c) Date: January 17, 2007 Title: METHOD FOR FORMING THICK FILM PATTERN, METHOD FOR MANUFACTURING ELECTRONIC COMPONENT, AND PHOTOLITHOGRAPHY PHOTOSENSITIVE PASTE	Art Unit: 1795 Examiner: A. Eoff
---	---

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 22, 2009, please reconsider the above-identified application in view of the following remarks.

Listing of the Claims begins on page **2**. No amendments have been made to the Claims.

Remarks/Arguments begin on page **6** of this paper.